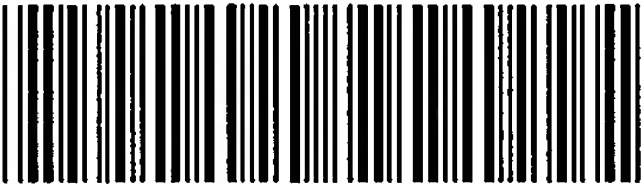


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/657,068	IWAMATSU ET AL.	
	Examiner	Art Unit	
	Andy Huynh	2818	

SEARCHED			
Class	Subclass	Date	Examiner
Update	search		
Text	search	2/11/2005	AH
257	51,347	10/16/2004	AH
	377,382		
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257	\$.ccls.		
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Class	Subclass	Date	Examiner
257	51,347	10/16/2004	AH
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	384,412		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST	2/11/2005	AH
EAST	10/16/2004	AH